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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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Sheet

1

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Complete if Known

Application Number	10/642,908
Filing Date	August 18, 2003
First Named Inventor	Tan et al.
Group Art Unit	2812
Examiner Name	A. Roman
Attorney Docket Number	2269-5163.1US (01-0910.01/US)

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner
Signature

Ans Ans

Date
Considered

03/08/05

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PTO/SB/08A (10-01)

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of

Sheet 1 of 1 Attorney Docket Number 2269-5163.1US (01-0910.01/US)

<i>Complete if Known</i>	
Application Number	10/642,908
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First Named Inventor	Tan et al.
Group Art Unit	3712
Examiner Name	A. Roman
Attorney Docket Number	2269-5163.1US (01-0910.01/US)

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Examiner
Signature

Mr. R.

**Date
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03/08/05

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Sheet 1 of 3

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Application Number	10/642,908
Filing Date	August 18, 2003
First Named Inventor	Tan et al.
Group Art Unit	3712
Examiner Name	Unknown
Attorney Docket Number	5163.IUS (01)-09J0.01/US

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

Examiner Signature  Date Considered 04/13/05
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Sheet

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First Named Inventor	Tan et al.
Group Art Unit	3712
Examiner Name	Unknown
Attorney Docket Number	5163 IJS (01-0910.01/IJS)

OTHER PRIOR ART -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AR		U.S. Patent Application Publication 2002/0171177 A1 to Krichman et al., dated November 21, 2002.	
AR		U.S. Patent Application Publication 2003/0043360 A1 to Farnworth, dated March 6, 2003	
AR		U.S. Patent Application Publication 2003/0151167 A1 to Krichman et al., dated August 14, 2003	
AR		U.S. Patent Application Publication 2003/0207213 A1 to Farnworth, dated November 6, 2003	
AR		MILLER et al., "Maskless Mesoscale Materials Deposition", Deposition Technology, September 2001, pages 20-22	
AR		MILLER, "New Laser-Directed Deposition Technology", Microelectronic Fabrication, August 2001, page 16	
AR		Webpage, Objet Prototyping the Future, "Objet FullCure700 Series", 1 page	
AR		Webpage, Objet Prototyping the Future, "How it Works", 2 pages	
AR		U.S. Patent Application No. 10/191,424, filed July 8, 2002, entitled "Semiconductor Devices With Permanent Polymer Stencil and Method for Manufacturing the Same", inventor Farnworth et al.	
AR		U.S. Patent Application No. 10/201,208, filed July 22, 2002, entitled "Thick Solder Mask for Confining Encapsulant Material Over Selected Locations of a Substrate, Assemblies Including the Solder Mask, and Methods, inventor Grigg et al.	
AR		U.S. Patent Application No. 10/370,755, filed February 20, 2003, entitled "Chip Scale Package Structures and Method of Forming Conductive Bumps Thereon", inventor Warren M. Farnworth	

Examiner Signature	AR	Date Considered	03/08/05
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		Examiner Name	Unknown
Sheet	3	of	3
		Attorney Docket Number	5163 11S (01-09-10.01/US)

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials *	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
AR		U.S. Patent Application No. 10/672,098, filed September 26, 2003, entitled "Apparatus and Methods for Use in Stereolithographic Processing of Components and Assemblies", inventor Warren M. Farmworth	
AR		U.S. Patent Application No. 10/688,354, filed October 17, 2003, entitled "Thick Solder Mask for Confining Encapsulant Material Over Selected Locations of a Substrate and Assemblies Including the Solder Mask", inventor Grigg et al.	

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